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Response

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Landon B. Vines *et al.*

Serial No. 09/871,507

Filed: 5/31/2001

For: A CMP Polisher Substrate Removal Control
Mechanism and Method

Group: 3723

Examiner: Willie Berry, Jr.

Docket No.: US 018074

RESPONSE TO FEBRUARY 6, 2003 OFFICE ACTION

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

In response to the Office Action dated February 6, 2003, please consider the following amendments and remarks. Please note that an SB-122 Change of Correspondence Address has been included with this Office Action Response.

Introductory Comments

Applicants appreciate Examiner's withdrawal of the finality of the previous Office Action and continuing the examination of the present application. Applicants respectfully request his thoughtful consideration of the discussion presented and allowance of the claimed invention. Claims 1 – 20 remain pending in the application.

**FACSIMILE TRANSMISSION
TO THE UNITED STATES PATENT AND TRADEMARK OFFICE**

TO: EXAMINER Willie Wendell Berry, Jr.
ART UNIT 3723
EXAMINER'S FAX NUMBER (703) 872-9302

FROM: Peter S. Zawilski

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RE: SERIAL NO. 09/871,507
DOCKET NO. US 018074

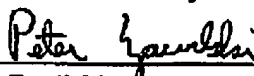
8 Pages (including cover sheet)

This transmission includes:

SB-122 Change of Correspondence Address (1 pg.)
Response to Office Action 02-FEB-2003 (6 pgs.)

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I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office
on May 1, 2003.


Peter Zawilski

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